

ABSTRACT

Lithographic Apparatus and Device Manufacturing Method.

A lithographic projection apparatus, in which a conduit supplies utilities to a movable component in a vacuum chamber such as an object table, associated motor or sensor. The conduit comprises flexible metal bellows preventing out-gassing of the conduit due to the vacuum in the vacuum chamber while
5 allowing movement of the movable component in at least a first degree of freedom.

Figure 2



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